Atty. Dkt. No.: 39153/306 (F0793)

CLAIMS

WHAT IS CLAIMED IS:

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1	- 1.	A lithographic system for an integrated circuit fabrication
2	process, the	lithographic system comprising:
3		a computer; and
4		a configurable mask or reticle coupled to the computer,
5	wherein the	configurable mask or reticle allows light to be transmitted in a
6	pattern cont	rolled by a control signal from the computer.
1	2.	The lithographic system of claim 1, wherein the configurable
2	mask or reti	cle is an LCD or LED matrix.
1	3.	The lithographic system of claim 1 further comprising:
2	1	a database for providing mage information associated with a
3	device to be	patterned on a wafer the computer using the image
4	information	to generate the control signal.
1	, 4.	The lithographic system of claim 3, wherein the database is
2	stored on a	storage media.
1	5/	The lithographic system of claim 3, wherein the image
2	information	is related to transistor structures.
1	6.	The lithographic system of claim 1, wherein the control
2	signal is a vi	ideo signal.
1	5UB) 7.	A method of manufacturing an integrated circuit, the method
2	comprising:	

Atty. Dkt. No.: 39153/306 (F0793)

3		providing a pattern of radiation via an LCD or LED assembly;
4	and	/B
5		performing a semiconductor fabrication process in
6	accordance	with the pattern of radiation.
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1	8.	The method of claim 7, further comprising:
2		providing a second pattern of radiation via the LCD or LED
3	assembly; ar	/
4		performing a second/semiconductor fabrication process in
5	accordance	with the second partern of radiation.
1	9.	The method of claim 7, wherein the pattern is provided to a
2	wafer in a st	tep and repeat process
1	10.	The method of claim 7, wherein the pattern is representative
2	of a metal la	yer associated with the integrated circuit.
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1	11.	The method of claim 7, wherein the pattern is representative
2	of a structur	e associated with a transistor for the integrated circuit.
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15	12.	The method of dain 7, wherein a representation of the
2	pattern is st	ored electronically.
1	13.	The method of claim 7, wherein the integrated circuit is an
2	ASIC.	
1	14.	The method of claim 7, wherein the pattern is provided via
2	the LCD ass	embly. ℓ
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1	15.	A pattern generator for an integrated circuit fabrication
2	system, the	pattern generator domprising:

Atty. Dkt. No.: 39153/306 (F0793)

3		means for providing a pattern of light; and
4		means for controlling the means for providing, wherein the
5	means for c	ontrolling selects the pattern.
1	16.	The pattern generator of claim 15, further comprising:
2		means for providing a light through the means for providing a
3	pattern.	
1	17.	The pattern generator of claim 16, further comprising:
2		means for focusing the light on a wafer.
1	18.	The pattern generator of claim 15, further comprising:
2		means for storing elements, wherein the means for
3	controlling o	creates a control signal representative of the pattern in
4	response to	the elements.
1	19.	the pattern generator of claim 15, wherein the means for
2	controlling	ncludes a workstation executing a software program.
1	20.	The pattern generator of claim 19, wherein the means for
2	providina a	nattern includes liquid crystals.